Characterization of the ion-amorphization process and thermal annealing effects on third generation SiC fibers and 6H-SiC

Juan Huguet-Garcia, Aurélien Jankowiak, Sandrine Miro, Renaud Podor, Estelle Meslin, Lionel Thomé, Yves Serruys, Jean-Marc Costantini

To cite this version:


HAL Id: cea-01370179
https://hal-cea.archives-ouvertes.fr/cea-01370179
Submitted on 29 Apr 2019

HAL is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L’archive ouverte pluridisciplinaire HAL, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d’enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.
Characterization of the ion-amorphization process and thermal annealing effects on third generation SiC fibers and 6H-SiC

Juan Huguet-Garcia1*, Aurélien Jankowiak1, Sandrine Miro2, Renaud Podor3, Estelle Meslin4, Lionel Thomé5, Yves Serruys2, and Jean-Marc Costantini1

1 CEA, DEN, Service de Recherches Métallurgiques Appliquées, 91191 Gif-sur-Yvette, France
2 CEA, DEN, Service de Recherches en Métallurgie Physique, Laboratoire JANNUS, 91191 Gif-sur-Yvette, France
3 ICSM-UMR5257 CEA/CNRS/UM2/ENSCM, Site de Marcoule, bâtiment 426, BP 17171, 30207 Bagnols-sur-Cèze, France
4 CEA, DEN, Service de Recherches en Métallurgie Physique, 91191 Gif-sur-Yvette, France
5 CSNSM, CNRS-IN2P3, Université Paris-sud, 91405 Orsay, France

Received: 11 June 2015 / Received in final form: 14 September 2015 / Accepted: 24 September 2015
Published online: 09 december 2015

Abstract. The objective of the present work is to study the irradiation effects on third generation SiC fibers which fulfill the minimum requisites for nuclear applications, i.e. Hi-Nicalon type S, hereafter HNS, and Tyranno SA3, hereafter TSA3. With this purpose, these fibers have been ion-irradiated with 4 MeV Au ions at room temperature and increasing fluences. Irradiation effects have been characterized in terms of micro-Raman Spectroscopy and Transmission Electron Microscopy and compared to the response of the as-irradiated model material, i.e. 6H-SiC single crystals. It is reported that ion-irradiation induces amorphization in SiC fibers. Ion-amorphization kinetics between these fibers and 6H-SiC single crystals are similar despite their different microstructures and polytypes with a critical amorphization dose of $\sim 3 \times 10^{13} \text{cm}^{-2}$ ($\sim 0.6 \text{dpa}$) at room temperature. Also, thermally annealing-induced cracking is studied via in situ Environmental Scanning Electron Microscopy. The temperatures at which the first cracks appear as well as the crack density growth rate increase with increasing heating rates. The activation energy of the cracking process yields 1.05 eV in agreement with recrystallization activation energies of ion-amorphized samples.

1 Introduction

Future nuclear applications include the deployment of the so-called Generation IV fission and fusion reactors, which are devised to operate at higher temperatures and to higher exposition doses than nowadays nuclear reactors. One of the critical issues to the success of future nuclear applications is to develop high performance structural materials with good thermal and radiation stability, neutron transparency and chemical compatibility [1].

Structural materials for nuclear applications are exposed to high temperatures, aqueous corrosive environments and severe mechanical loadings while exposed to neutron and ion irradiation. Its exposure to incident energetic particles displaces numerous atoms from the lattice sites inducing material degradation. Such degradation is the main threat to the safe operation of core internal structures and is manifested in several forms: radiation hardening and embrittlement, phase instabilities from radiation-induced or enhanced precipitation, irradiation creep and volumetric swelling [2]. As can be observed in Figure 1, nominal temperatures and displacement doses can reach up to 1100°C and 200dpa depending on the nuclear reactor design. As a consequence, conventional nuclear materials, mostly metallic alloys, do not meet the requirements to operate neither under nominal nor accidental conditions.

Nuclear grade Silicon Carbide based composites – made of third generation SiC fibers densified via chemical vapor infiltration (CVI) with a SiC matrix; SiCf/SiCm – are among the most promising structural materials for fission and fusion future nuclear applications [3]. However, several remaining uncertainties place SiCf/SiCm in a position that requires further research and development, notably the radiation behavior of the fiber reinforcement which is crucial for the composite radiation stability.

The objective of the present work is to study the irradiation effects on third generation SiC fibers which fulfill the minimum requisites for nuclear applications, i.e. Hi-Nicalon type S, hereafter HNS, and Tyranno SA3, hereafter TSA3. With this purpose, these fibers have been ion-irradiated at room temperature to different doses under...
elastic energy loss regimes to simulate neutron damage. The irradiation effects have been characterized in terms of micro-Raman Spectroscopy (µRS), Transmission Electron Microscopy (TEM) and Environmental Scanning Electron Microscopy (E-SEM) and compared to the response of the as-irradiated model material, i.e. 6H-SiC single crystals.

2 Materials and methods

2.1 6H-SiC single crystals and third generation SiC fibers

6H-SiC single crystals of 246µm thickness were machined from N-doped (0001)-oriented 6H-SiC single crystal wafers grown by CREE Research using a modified Lely method. Crystals were of n-type with a net doping density (n_D–n_A) of 10^{17} cm^{-3}. All samples were polished to achieve a microelectronics “epiready” quality.

Main characteristics of HNS and TSA3 fibers are summarized in Table 1. Figure 2 shows TEM images of the microstructures of both fibers. Both fibers consist in highly faulted 3C-SiC grains and intergranular pockets of turbostratic C visible as white zones in Figure 2. Stacking Faults (SFs) in SiC grains are clearly observed for both fibers as striped patterns inside the grains. Stacking fault linear density yields 0.29±0.1 nm^{-1} for HNS fibers and 0.18±0.1 nm^{-1} for TSA3 fibers. It has been determined by counting the number of stripes per unit length in the perpendicular direction using ImageJ [4] image analysis software. Also, mean maximum and minimum Feret diameters – which correspond to the shortest and the longest distances between any two points along the grain boundary (GB) – were determined. These values yield, respectively, 26 and 36nm for the HNS fibers and 141 and 210nm for the TSA3 fibers [5].

2.2 Ion-irradiation

Different 6H-SiC single crystals and SiC fibers were irradiated at room temperature (RT) with 4 MeV Au^{2+} to 5 × 10^{12}, 10^{13}, 5 × 10^{13}, 10^{14}, 2 × 10^{14}, 3 × 10^{14}, 10^{15} cm^{-2} at JANNUS-Orsay facility and to 2 × 10^{15} cm^{-2} at JANNUS-Saclay facility [8]. To evaluate the irradiation

![Fig. 1. Nominal operating temperatures and displacement doses for structural materials in different nuclear applications. The acronyms are defined in the Nomenclature section (adapted from Ref. [2]).](image)

![Fig. 2. TEM images of the as-received (a) HNS and (b) TSA3 fibers. Stripped patterns inside the grains indicate the high density of stacking faults in both samples (reproduced from Ref. [5]).](image)

<table>
<thead>
<tr>
<th>Fiber</th>
<th>Main characteristics of third generation SiC fibers.</th>
</tr>
</thead>
<tbody>
<tr>
<td>Fiber</td>
<td>Producer</td>
</tr>
<tr>
<td>-------</td>
<td>-----------</td>
</tr>
<tr>
<td>Fiber</td>
<td>Tyran SA3</td>
</tr>
<tr>
<td></td>
<td>Hi-Nicalon type S</td>
</tr>
<tr>
<td></td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
</tr>
</tbody>
</table>

Table 1. Main characteristics of third generation SiC fibers.

*Values correspond to the edge and core of the fiber respectively.
Min. and max. Feret diameters.
damage, ion-fluences have been converted to dpa with equation (1):

$$dpa = \frac{\varphi}{\rho_{\text{SiC}} \text{[atoms cm}^{-3}\text{]}} \times \frac{10^8}{\varphi_{\text{ions cm}^{-2}}}$$

where $\varphi$ is the ion fluence, $\rho_{\text{SiC}}$ the theoretical density of SiC (3.21 g cm$^{-3}$) and $\varphi_{\text{ions cm}^{-2}}$ the vacancy per ion ratio given by SRIM-2010 calculations [9]. Figure 3 shows the vacancy per ion ratio and the implantation profiles as a function of the SiC depth. SRIM calculations have been performed with full damage cascades. Threshold displacement energies for C and SiC atoms cm$^{-2}$ have been converted to dpa with \(1000^\circ C\) and the high SF density observed in Figure 2.

### 3 Results and discussion

#### 3.1 Third generation SiC fibers microstructure and Raman spectra

$\mu$RS is a powerful characterization technique based on the inelastic scattering of light due to its interaction with the material atomic bonds and the electron cloud providing a chemical fingerprint of the analyzed material. SiC is known to have numerous stable stoichiometric solid crystalline phases, so-called polytypes, the cubic (3C-SiC) and the hexagonal (6H-SiC) being the most common ones [12]. Raman peak parameters such as intensity, bandwidth and wavenumber provide useful information related to the phase distribution and chemical bonding of SiC and SiC fibers [13]. Table 2 gathers the characteristic Raman peak wavenumber for 3C- and 6H-SiC polytypes.

Figure 4 shows the collected Raman spectra for the as-received samples. For the 6H-SiC spectrum, group-theoretical analysis indicates that the Raman-active modes of the wurtzite structure (C$_{6v}$ symmetry for hexagonal polytypes) are the A$_1$, E$_1$ and E$_2$ modes. In turn, A$_1$ and E$_1$ phonon modes are split into longitudinal (LO) and transverse (TO) optical modes. Also, the high quality of the sample allows the observation of second order Raman bands as several weaker peaks located at 500 cm$^{-1}$ and between 1400–1850 cm$^{-1}$.

Raman spectra collected from as-received TSA3 and HNS fibers differ notably from the single crystal one. Their polycrystalline microstructure and the intergranular free C shown in Figure 2 induce the apparition of several peaks related to their chemical fingerprint. Peaks located between the 700 cm$^{-1}$ and 1000 cm$^{-1}$ are related to the cubic SiC polytype. Satellite peaks around 766 cm$^{-1}$ are attributed to disordered SiC consisting of a combination of simple polytype domains and nearly periodically distributed stacking faults [13,14]. This explanation is consistent with the high SF density observed in Figure 2.

High-intensity peaks located between 1200 cm$^{-1}$ and 1800 cm$^{-1}$ are attributed to the intergranular free C despite the little free C content of both fibers. The high contribution of these peaks to the spectra is due to the high Raman cross-section of C–C bonds which is up to ten times higher than the Si–C bonds [15]. Regarding the C chemical fingerprint, the G peak centered around 1581 cm$^{-1}$ is related to graphitic structures as a result of the sp$^2$ stretching modes of C bonds and the D peak centered around 1331 cm$^{-1}$, according to Colomban et al. [13], should be attributed to vibrations.
involving sp$^3$–sp$^{2/3}$ bonds. Finally, the shouldering appearing on the G band in both fibers, D'$, results from the folding of the graphite dispersion branch corresponding to G at Γ point.

There is a remarkable difference in the G peak intensity between TSA3 and HNS fibers. It has been stated that the G over D peak intensity ratio is proportional to the in-plane graphitic crystallite size [17]. Therefore, the smaller size of the intergranular free C pockets of HNS takes account for such difference.

### 3.2 Ion-irradiation-induced amorphization

During service as nuclear structural material, SiC composites will be subjected to neutron and ion-irradiation. When an energetic incident particle elastically interacts with a lattice atom, there is a kinetic energy exchange between them. If this transmitted energy is higher than the threshold displacement energy of the knocked lattice atom, it will be ejected from its equilibrium position giving birth to a Frenkel pair: a vacancy and an interstitial atom. In turn, if the kinetic energy transfer is high enough, the displaced atom may have enough kinetic energy to displace not only one but many atoms of the lattice, which, in turn, will cause other displacement processes giving birth to displacement cascade. The number of surviving defects after the thermal recombination of the displacement cascade may pile up dealing to the degradation of the exposed material [18].

Ion-irradiation has been widely used by the nuclear materials community to simulate neutron damage due to the tunability of the radiation parameters (dose, dose rate, temperature) and the similarity of the defect production in terms of displacement cascade creation [19].

In this work, the samples have been irradiated to increasing fluences at RT with 4 MeV Au ions in order to simulate neutron damage. Figure 5 shows the evolution of the Raman spectra as a function of the irradiation dose. As can be observed, ion-irradiation induces sequential broadening of the Si–C bond related peaks until they combine in a unique low-intensity broad peak. Also, ion-irradiation induces the appearance of new low-intensity broad peaks at ~500 cm$^{-1}$ and ~1400 cm$^{-1}$. These changes with dose in the Raman spectra are the consequence of the increasing damage of the crystal lattice and are usually attributed to the dissociation of the Si–C bonds and the creation of Si–Si and C–C homonuclear bonds [20], in agreement with EXAFS [21] or EELS [22] data and theoretical analyses [23]. However, some authors have pointed out that changes...
in the Raman spectra in SiC for moderated irradiation damage do not necessarily imply the formation of Si and C homonuclear bonds. For instance, the abrupt end of the broad band observed near the 950 cm\(^{-1}\) C–C bond.

The abrupt end of the damage do not necessarily imply the formation of Si and C in the Raman spectra in SiC for moderated irradiation crystal and third generation SiC Fig. 5. It is worth to highlight that in SiC fibers irradiation at low doses increases the intensity of the Si–C related peak despite its randomization. As commented, there is a remarkable influence of the free C in the SiC fibers Raman spectra due to the high Raman cross-section of C–C bonds. Under irradiation, the rupture of these bonds will imply the drop of its cross-section allowing the SiC Raman signal to emerge over the free C one. Finally, the spectra show similar low-intensity broad peaks at \(\sim 800\) cm\(^{-1}\) characteristic of amorphous SiC. As can be observed in Figure 6, complete amorphization of the ion-irradiated layer is confirmed by TEM imaging and electron diffraction of samples irradiated to 4 dpa (\(2 \times 10^{15}\) cm\(^{-2}\)). SAED patterns of these zones are composed of diffuse concentric rings.

Ion-amorphization kinetics for 6H-SiC single crystals has been previously studied by \(\mu\)RS in terms of the total disorder parameter and the chemical disorder. The former is defined as \((1/A/A_{\text{cryst}})\) corresponding to the total area \(A\) under the principal first-order lines normalized to the value \(A_{\text{cryst}}\) of the crystalline material. The latter is defined as the ratio of C–C homonuclear bonds to Si–C bonds and denoted as \(\chi_{\text{(C–C)}}\), ranging from zero for perfect short-range order to unity for random short-range disorder. Short-range order describes the degree of the chemical state with respect to the local arrangement of atoms, which can be partially preserved even when the LRO is completely lost [20,25].

In our work, the use of these parameters to study the ion-amorphization of SiC fibers is limited by two factors. First, the Si-C signal increases at low doses, hence invalidating \(A/A_{\text{norm}}\) as an indicative of the total disorder evolution, and secondly, the enormous impact of the free C of the as-received fibers in their Raman spectra, hence invalidating \(\chi_{\text{(C–C)}}\) as a good indicative of the short-range order evolution. In order to overcome these limitations, chemical disorder has been calculated as the ratio of Si–Si homonuclear bonds to Si–C bonds \((\chi_{\text{(Si–Si)}})\) under the assumption that the intensity of the Raman peaks is proportional to the concentration of the related atomic bond [20].

Figure 7 shows the \(\chi_{\text{(Si–Si)}}\) evolution as a function of the dose for the three samples. Data has been fitted with a multistep damage accumulation (MSDA) model given by equation (2):

\[
f_d = \sum_{i=1}^{n} \left[ \left( \frac{f_{\text{sat}}}{f_{d,i}} - f_{\text{sat}} \right) \left( 1 - e^{-\sigma_i (\psi - \psi_{i-1})} \right) \right]
\]

where \(n\) is the number of steps in damage accumulation, \(f_{d,i}\) the level of damage saturation for the step \(i\), \(\sigma_i\) the damage cross-section for the step \(i\), and \(\psi\) and \(\psi_{i-1}\) the dose and the saturation dose of the \(i\)th step [26].

MSDA model assumes that damage accumulation is a sequence of distinct transformations of the current structure of the irradiated material and that reduces to a direct impact (DI) model meaning that amorphization is achieved in a single cascade [26]. Table 3 gathers the best-fit (non-linear least-squares Marquardt-Levenberg algorithm) parameters for \(n = 2\) of the \(\chi_{\text{(Si–Si)}}\) evolution with dose.

MSDA parameters for 6H-SiC amorphization kinetics are consistent with previous reported ones based in RBS and \(\mu\)RS data [25,27] hence confirming \(\chi_{\text{(Si–Si)}}\) as a relevant indicative for the amorphization level of the sample.

According to the MSDA parameters, there is a significant difference in the first stage of the amorphization process between SiC fibers and 6H-SiC. However, this difference may arise from the difficulty to treat the Raman spectra of SiC fibers due to their C signal so it cannot be directly attributed to a prompt amorphization. More experimental data is needed to confirm this hypothesis.
On the other hand, all irradiated samples show an inflexion point around \(10^{14} \text{cm}^{-2} \) \(0.2 \text{dpa}\) and reach the saturation value over \(3 \times 10^{14} \text{cm}^{-2} (0.6 \text{dpa})\). Therefore, it can be asserted that the three samples present a two-step amorphization process regardless of their different polytype, composition and microstructure.

It is widely accepted that GBs act as point defect sinks \([28]\). However, the grain size must be optimized because a small grain size has two opposing effects on the free energy of an irradiated material. For instance, a smaller grain size hinders intragranular point defects accumulation which, in turn, decreases the free energy resulting from irradiation-induced defects. However, a smaller grain size also may increase the free energy resulting from the increase on the GB density which can favor the path toward an amorphous phase \([29]\). The microstructure influence of the behavior of SiC under irradiation is controversial as both experimental and computational studies can be found concerning whether grain refinement enhances or reduces SiC radiation resistance \([30–33]\). The similar ion-amorphization doses of 6H-SiC, TSA3 and HNS suggest that the microstructure of these fibers is not refined enough to show significant enhanced or reduced radiation resistance – not even for the HNS fibers which grain sizes are around 20nm.

3.3 In situ E-SEM thermal annealing

Radiation-induced amorphization is detrimental for the use of SiC under nuclear environments at low temperatures as it causes the degradation of the material’s physico-chemical properties \([34]\). Even though amorphous SiC (a-SiC) is known to be highly stable, irradiation-induced damage in SiC can be recovered and the a-SiC layer recrystallized by thermal annealing at high temperatures \([25,35]\). However,
it has been reported that thermal annealing has an undesirable side effect. As shown in Figure 8, it induces mechanical failure of the ion-amorphized layers in single crystals SiC [25,36] and in HNS fibers [37]. However, little information concerning thermal annealing-induced mechanical failure is available for SiC. It has been reported that thermal stresses – arising from a mismatch between the coefficient of thermal expansion of the irradiated layer and the pristine substrate – are not responsible for the mechanical failure [37] and recrystallization-related stresses have been pointed out as the cracking and delamination cause [36,37].

In order to provide further information on how recrystallization is related to mechanical failure, several thermal annealing tests on ion-amorphized 6H-SiC single crystals have been conducted and observed at different temperature ramps via in situ E-SEM.

Figure 9 shows the evolution of the linear crack density as a function of time for different heating rates. As it can be observed, crack density reaches similar saturation values independently of the heating rate whereas cracking kinetics are heating rate-dependent. For instance, both the temperatures at which cracking is triggered and the crack density growth rate increase with increasing heating rates.

Cracking kinetics appears to be thermally activated phenomenon. In order to obtain the characteristic activation energy ($E_a$) of the process, the experimental data have been assumed to obey an Arrhenius law. For instance, Figure 10 shows the log-plot of two characteristic features of the cracking phenomenon: the inverse of the time necessary to reach the 50% of the cracking density ($t_{50\%}$) as a function of the inverse of the sample temperature at time $t_{50\%}$, denoted as $T_{50\%}$. These two parameters have been successfully applied for the study of the recrystallization temperature of tungsten as a function of the heating rate [38]. Linear fit to the log-plot yields an $E_a$ of 1.05 eV. This value falls in the range of recrystallization activation energies.
4 Conclusions

In this work, ion-amorphization of SiC fibers has been studied in terms of surface $\mu$RS and TEM imaging and compared to the model material, i.e., 6H-SiC. It is reported that SiC fibers, HNS and TSA3, and 6H-SiC display a similar ion-amorphization process despite their different SiC polytypes and microstructures. Critical amorphization dose yields $\sim 3 \times 10^{18}$ cm$^{-2}$ ($\sim$0.6 dpa) for 4 MeV Au ions at RT.

Also, the kinetics of thermally annealing-induced cracking is studied via in situ E-SEM observations. It is reported that the temperatures at which the first cracks appear as well as the pace of crack density growth increase with increasing heating rates. The activation energy of the cracking process yields 1.05 eV in agreement with recrystallization activation energies of ion-amorphized samples. This observation supports recrystallization as the stress source causing the mechanical failure of the annealed samples.

The authors would like to thank JANNUS staffs for their technical support during irradiations and EMIR network for funding the irradiation time. Also we are grateful to B. Arnal and D. Troadec for FIB sample preparation and T. Vandenberge for TEM observations.

Nomenclature

<table>
<thead>
<tr>
<th>Symbol</th>
<th>Description</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\mu$RS</td>
<td>micro-Raman Spectroscopy</td>
</tr>
<tr>
<td>CVI</td>
<td>Chemical Vapor Infiltration</td>
</tr>
<tr>
<td>dpa</td>
<td>displacements per atom</td>
</tr>
<tr>
<td>DTA</td>
<td>Dose To Amorphization</td>
</tr>
<tr>
<td>E-SEM</td>
<td>Environmental Scanning Electron Microscope</td>
</tr>
<tr>
<td>GB</td>
<td>Grain Boundary</td>
</tr>
<tr>
<td>GENII</td>
<td>Generation II (current nuclear reactors)</td>
</tr>
<tr>
<td>GFR</td>
<td>Gas Fast Reactor</td>
</tr>
<tr>
<td>HNS</td>
<td>Hi-Nicalon type S</td>
</tr>
<tr>
<td>LFR</td>
<td>Lead Fast Reactor</td>
</tr>
<tr>
<td>MSDA</td>
<td>Multistep Damage Accumulation</td>
</tr>
<tr>
<td>MSR</td>
<td>Molten Salt Reactor</td>
</tr>
<tr>
<td>RBS</td>
<td>Rutherford Backscattering Spectrometry</td>
</tr>
<tr>
<td>SAED</td>
<td>Selected Area Electron Diffraction</td>
</tr>
<tr>
<td>SCWR</td>
<td>Super Critical Water Reactor</td>
</tr>
<tr>
<td>SFR</td>
<td>Sodium Fast Reactor</td>
</tr>
<tr>
<td>TEM</td>
<td>Transmission Electron Microscope</td>
</tr>
<tr>
<td>TSA3</td>
<td>Tyranno SA3</td>
</tr>
<tr>
<td>VHTR</td>
<td>Very High Temperature Reactor</td>
</tr>
</tbody>
</table>

References

26. J. Jagielski, L. Thomé, Damage accumulation in ion-irradiated ceramics, Vacuum 81, 1352 (2007)

Cite this article as: Juan Huguet-Garcia, Aurélien Jankowiak, Sandrine Miro, Renaud Podor, Estelle Meslin, Lionel Thomé, Yves Serruys, Jean-Marc Costantini, Characterization of the ion-amorphization process and thermal annealing on third generation SiC fibers and 6H-SiC, EPJ Nuclear Sci. Technol. 1, 8 (2015)